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FAX NO.

P. 01



Patent

Customer No.: 31561
Docket No. 12474-US-PA
Application No.: 10/711,379

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of
Applicant : Lu et al.
Application No. : 10/711,379
Filed : September 15, 2004
For : METHOD OF PLANARIZING SPIN-ON MATERIAL
LAYER AND MANUFACTURING PHOTORESIST LAYER
Art Unit : 2818
Examiner : NHU, DAVID

RESPONSE TO NOTICE REGARDING DRAWINGS

+1-703-746-4000
(Via fax: 1+9 pages)

U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Issue Fees
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Dear Sir,

In reply to the Notice Regarding Drawings mailed on August 26, 2005, transmitted herewith please find Replacement Sheets for corrected drawings in 9 pages.

Thank you for your assistance in the subject matter. If you have any questions, please feel free to contact me.

Respectfully Submitted,
JIANQ CHYUN Intellectual Property Office

Date: Sept. 13, 2005

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